Notice of References Cited

Application/Control No. 10/728,772	Reexaminati	Applicant(s)/Patent Under Reexamination RHEE ET AL.		
Examiner	Art Unit			
Mahmoud Dahimene	1765	Page 1 of 1		

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,413,854	07-2002	Uzoh et al.	438/637
	В	US-6,303,464	10-2001	Gaw et al.	438/422
	O	US-			
	D	US-			
	Ε	US-			·
	F	US-			
	G	US-			
	Н	US-			
	1	US-			
	J	US-			
	К	US-			
	L	US-			
	М	US-			·

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Q					
	R					
	S					
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	υ	S. Wolf and R.N. Ttauber, Silicon Processing for the VLSI Era, Volume 1- Process Technology, Lattice Press, 1986, Page 183.
	٧	S. Wolf , Silicon Processing for the VLSI Era, Volume 4- Deep Submicron Process Technology, Lattice Press, 2002, Page 654.
	w	
	x	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.